

Notice of References Cited	Application/Control No. 10/758,305	Applicant(s)/Patent Under Reexamination HARPER ET AL.	
	Examiner Jeff Wollschlager	Art Unit 1732	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,293,287	03-1994	Tzur et al.	360/98.03
*	C	US-2002/0025408	02-2002	Davis, John E.	428/141
*	D	US-6,696,220	02-2004	Bailey et al.	425/385
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	N	WO9801890	01-1998	WIPO	Granneman et al.	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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